

Notice of References CitedApplication/Control No.
09/276,803Applicant(s)/Patent Under
Reexamination
LEE ET AL.Examiner
Neal BereznyArt Unit
2823

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*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-6,162,744-A	02-1998	Al-Shareef et al.	438	785
	B	US- -				
	C	US- -				
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*	N	WO-96/02067-	01-1996	PCT	Azuma et al.	H01L	21/3205
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NON-PATENT DOCUMENTS

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	U	Wolf, S.; Tauber, R. N.; Silicon Processing For the VLSI Era: Vol. 1; Lattice Press; Sunset Beach, Ca.; 1986; pp. 57.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.